



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 15, 2024	
IGI Report Number	LG654411590
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	7.42 X 7.40 X 5.45 MM

GRADING RESULTS

Carat Weight	2.60 CARATS
Color Grade	F
Clarity Grade	VS 2

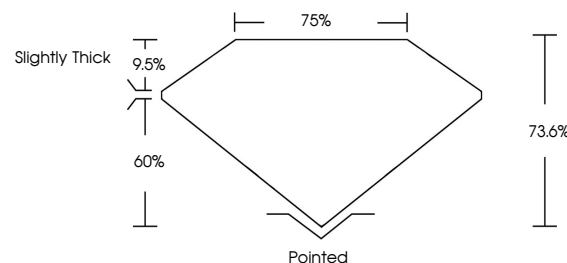
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG654411590

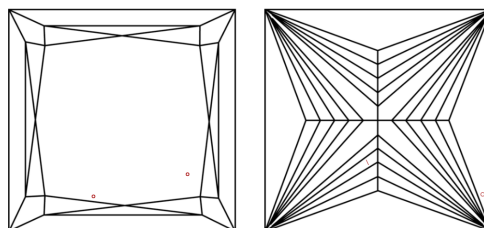
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG654411590
Report verification at igi.org

PROPORTIONS

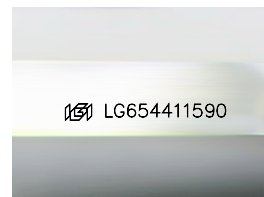


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

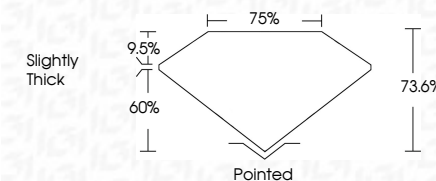
D E F G H I J Faint Very Light Light

CLARITY

IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Carat Weight	2.60 CARATS
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Clarity Grade	VS 2



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	1590 LG65441 1590
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



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www.igi.org



October 15, 2024
 IGI Report No LG654411590
 PRINCESS CIT

2.60 CARATS	F	VS 2	73.6%	76%	Slightly Thick	Pointed	EXCELLENT	EXCELLENT	NONE	4mm C456411350
Color Grade	Clarity Grade	Depth	Table	Grade		Clusht	Polish	Symmetry	Fluorescence	

Comments:
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